

# DIGITAL-TO-ANALOG BEAM ENERGY AND CURRENT STABILIZATION OF ELV ELECTRON ACCELERATORS

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ELV industrial electron beam accelerator is effective instrument for radiation treatment applications. Especially frequently it is used in cable and heat shrink tube manufacturing. Accelerator is only a part of technology line. There are underbeam transportation line, take-up and pay-off systems, safety system etc... All of them are controlled by signals from ELV control system, which are generated on base of the values as electron energy and beam current. There are 2 well-known methods of controlling the transportation line. The first: there ELV is master, line is slave (see Fig. 1). What things are the most important for this method?

For accelerator:  
 -stable parameters (better stability – less inhomogeneity of absorbed dose);  
 -smooth beam operation (fast beam current changes can break treated cable or tube).

For technology line:  
 -quick response for incoming parameters changes;

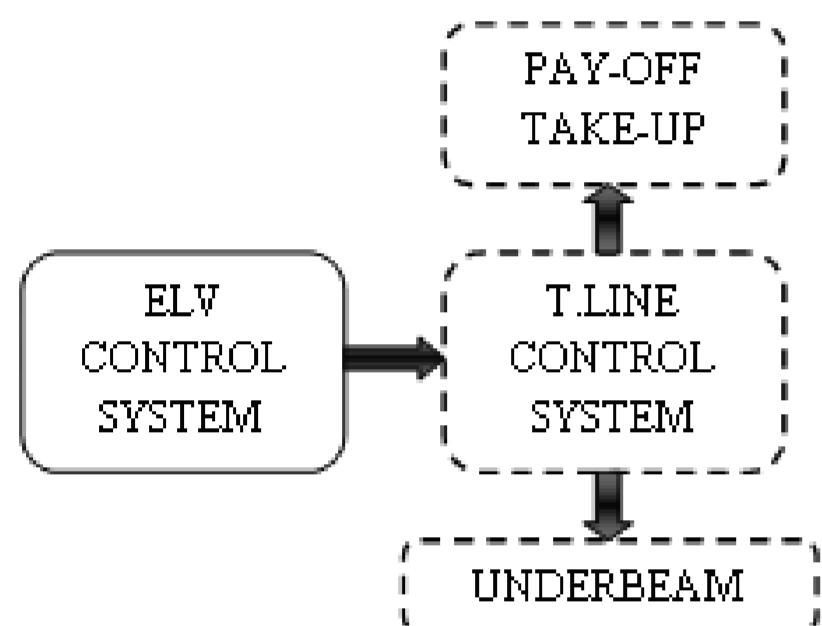


Figure 1: Accelerator is master.

$$E = E_{ref} - V_{bc} * k \quad (1)$$

E<sub>req</sub> – requested energy, MeV  
 V<sub>bc</sub> – beam current velocity, mA/sec  
 k – coefficient, MeV/mA/sec

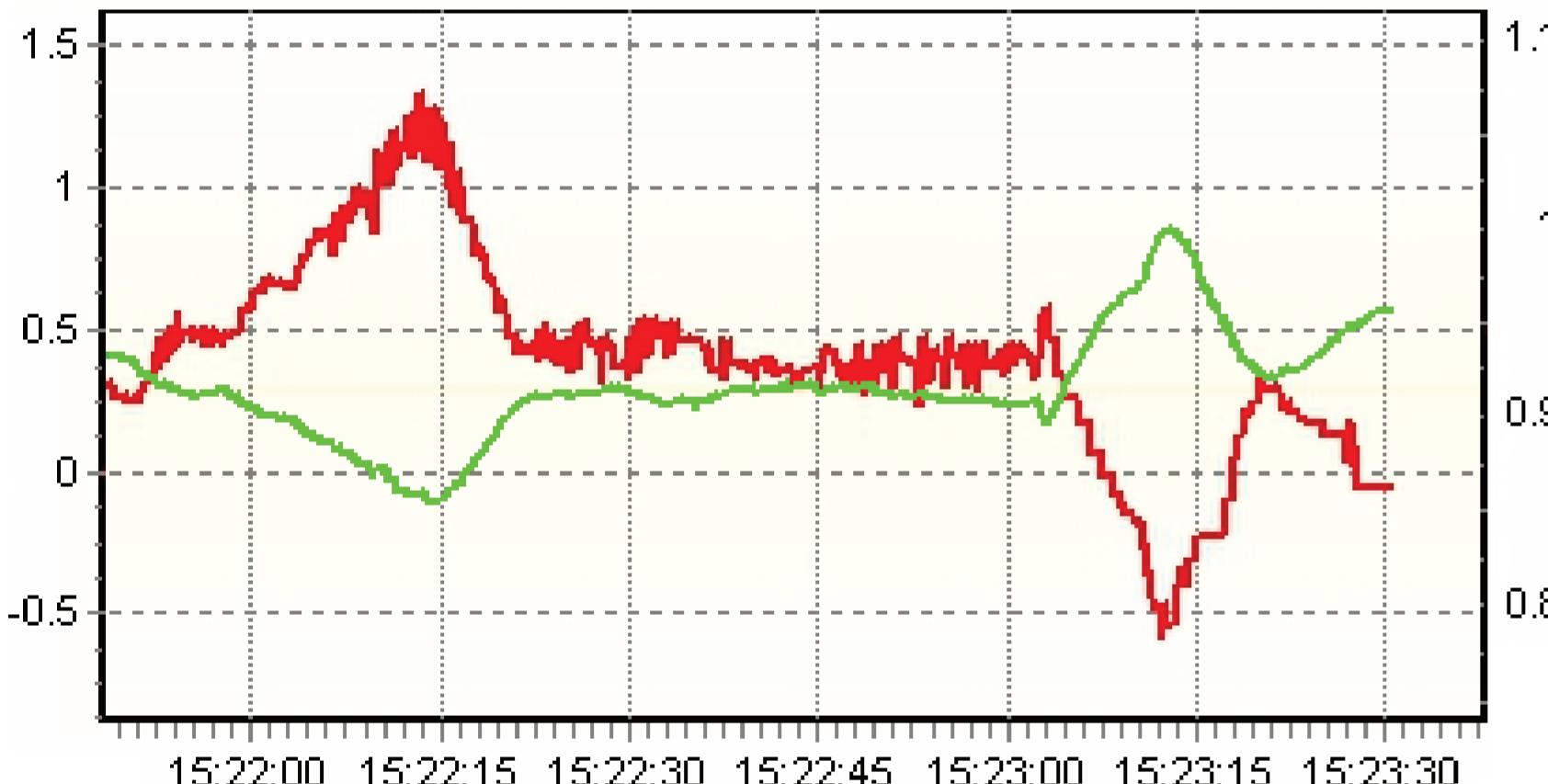
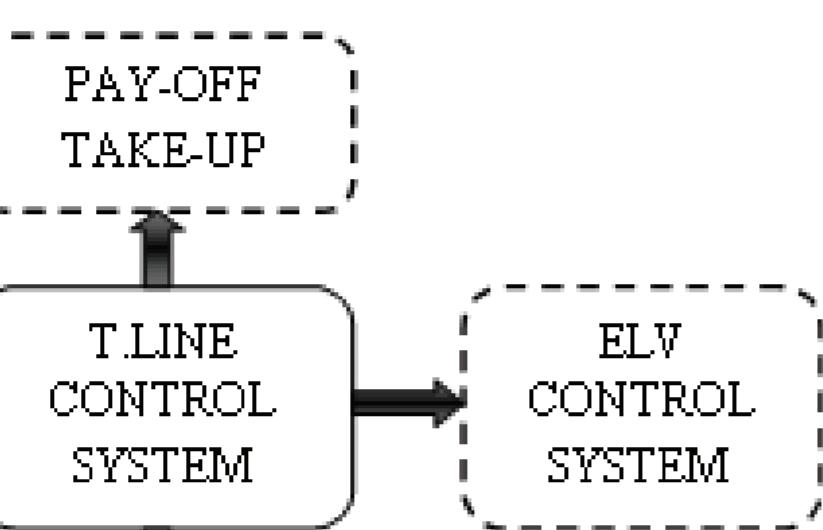


Figure 3: Energy(green line, right scale, MeV) and current velocity (red, left scale, mA/sec) curves.

New technologies of rubber component irradiation treatment are increasing the performance of technology lines, so they are using second method of links the accelerator to technology line. It led us to find possibility to increase the velocity of beam current control (speed of ascending/descending of beam current value).

Figure 2: Accelerator is slave.



Other method, where the accelerator is a slave, the technology line is a master, and accelerator parameters (beam current) follow production line velocity (see Fig. 2). Unlike the first method, here the most important things will be:

For accelerator:  
 -stable parameters (better stability – less inhomogeneity of absorbed dose);  
 -quick response for incoming parameters changes;

For technology line:  
 -smooth velocity;

Systems of energy and current stabilization are based on analog PID-controllers. They provide good stability at sufficient speed-work. Energy stabilization module is derivative calculator. Each 0.01 - 0.1 system separated from current stabilization. It is enough fast (time constant is 0.5 sec) for 100 kW accelerator. Energy stabilizer output is directly connected to Pulse Width Modulator of power supply cabinet, and has feedback from energy sensor (it can be resistive divider or rotary voltmeter).

Finally, for accelerate beam current velocity we added three modules into accelerator software. First module is derivative calculator. Each 0.01 - 0.1

second this module calculate difference from previous and present beam current value. Output value is a beam current velocity, which is to be used in other two modules (see Fig. 4, new modules inside dotted line).

Second module is energy compensator. Using equation (see Eq. 1) and current velocity as an argument, module generates offset that will be mixed with energy DAC signal. This provides better stability of accelerator energy during beam current ascending or descending.

Third module is current velocity booster. This module controls beam current velocity by generating offset for input of current stabilizer PID. Algorithm keep the velocity in predefined range, for example between 2 mA/sec and 3 mA/sec. If the velocity is not enough, the function will increase the beam current offset, which will be mixed with the current DAC signal. If the velocity is too high, the offset will be decreased. Adjusting this range, we can increase or decrease beam current ascending speed.

Results:

Improved stabilization systems provide current velocity up to 5 mA per sec. Modern ELV accelerators can work in a slave mode as part of technology lines with strict requirements to performance and response. Present system passed through the testing and it is already installed onto ELV-0.5 (0.5MeV 100mA) accelerator in Qingzhou (automobile tire production) and onto ELV-8(2.5MeV 40mA) accelerators in China for cable insulation treatment.

$$DAC_{current} = I_{offset} * \left( \frac{Current\ point}{End\ point} \right)^2 + I_{ref}$$

I<sub>offset</sub> – beam current offset  
 I<sub>ref</sub> – reference beam current  
 Current and end points – current and final beam current value

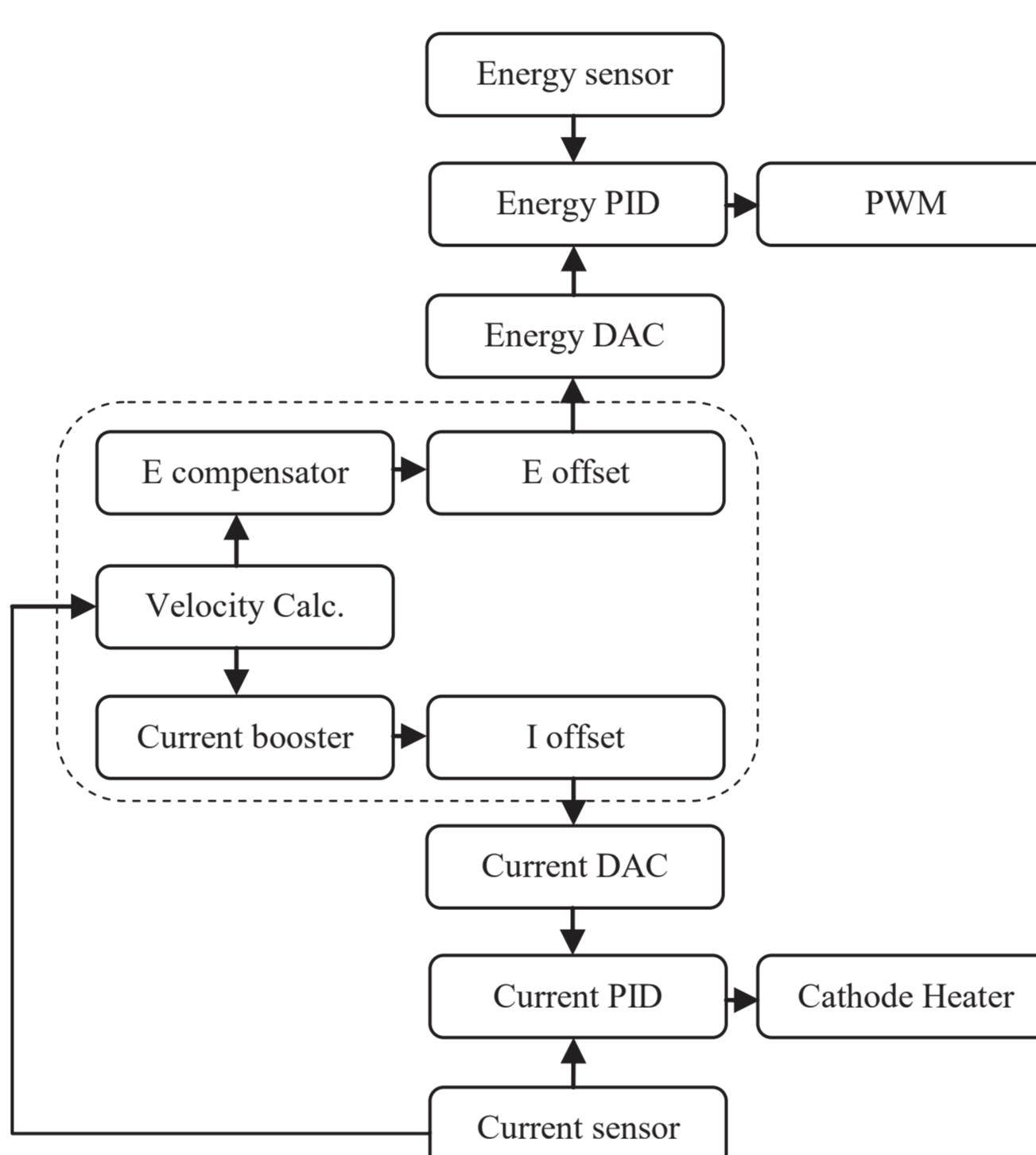


Figure 4: Schematic diagram of stabilization systems.

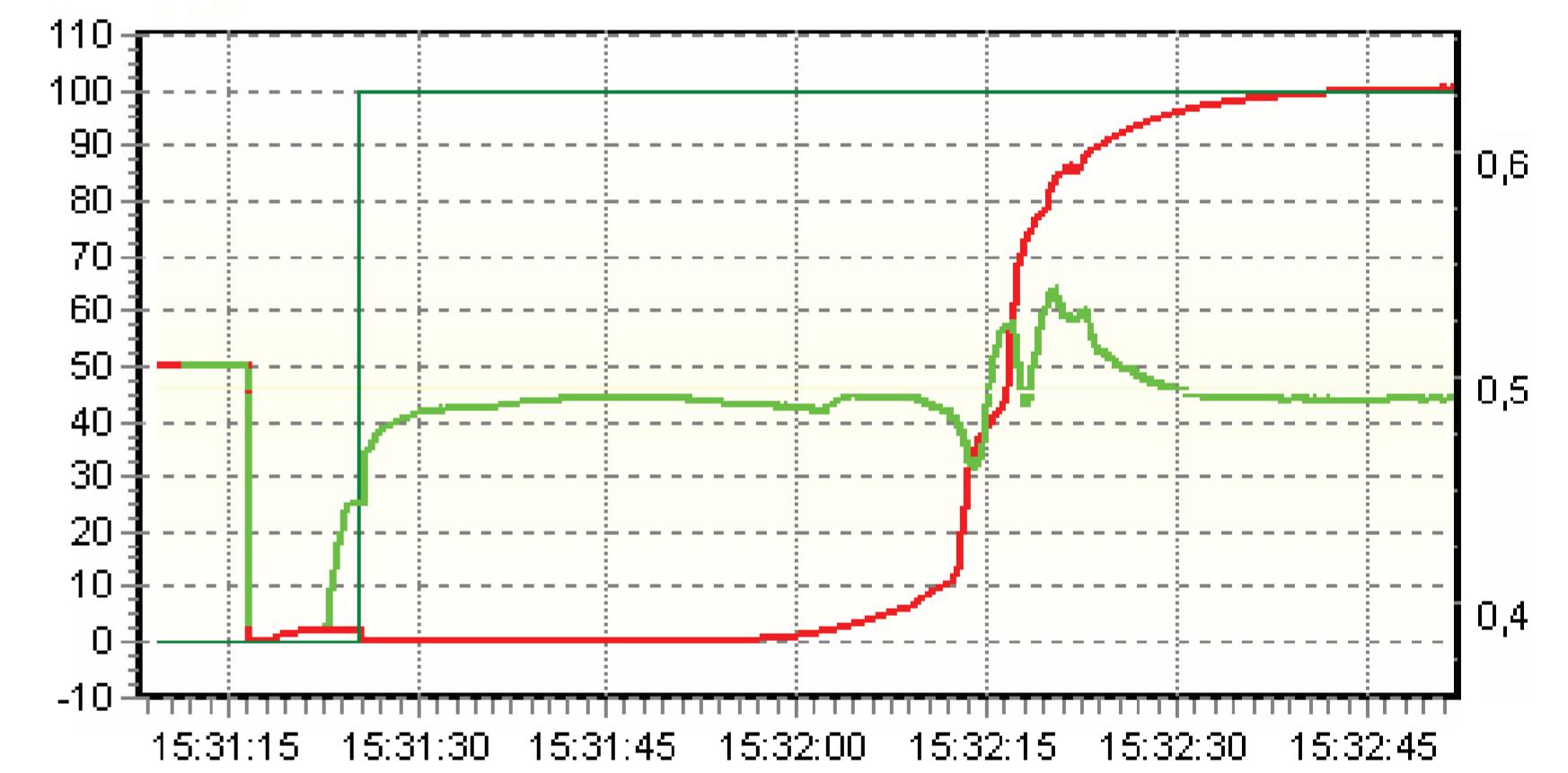


Figure 5: Energy(green line, right scale, MeV) and beam current (red, left scale, mA), ultra-fast rising.

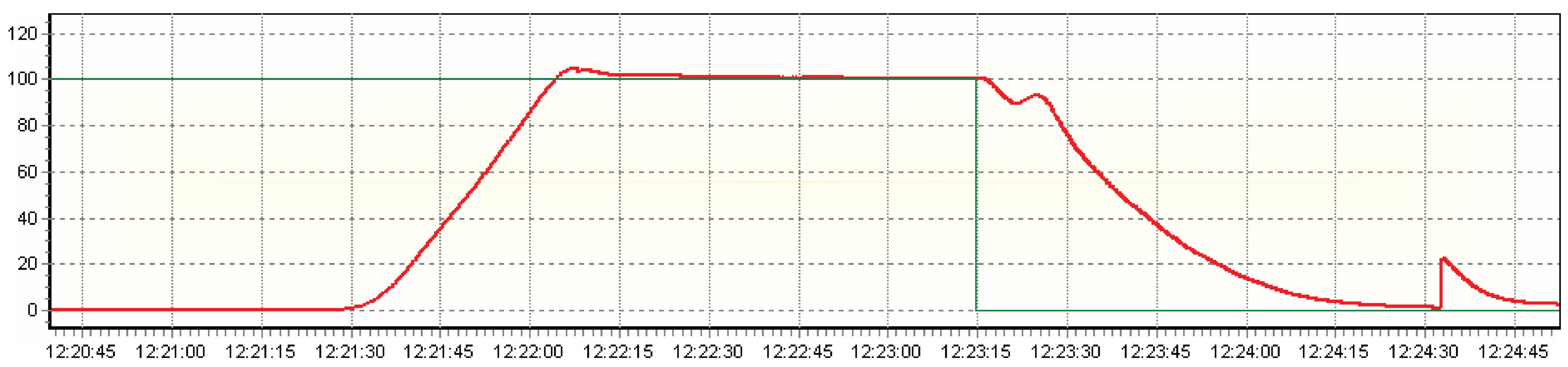


Figure 6: Beam current (red line), mA. Parameters was recorded on accelerator ELV-0.5 (0.5 MeV, 100 mA). Rising time ~30 sec.



Figure 7: Accelerator ELV-0.5, and technology line in Qingzhou, China.

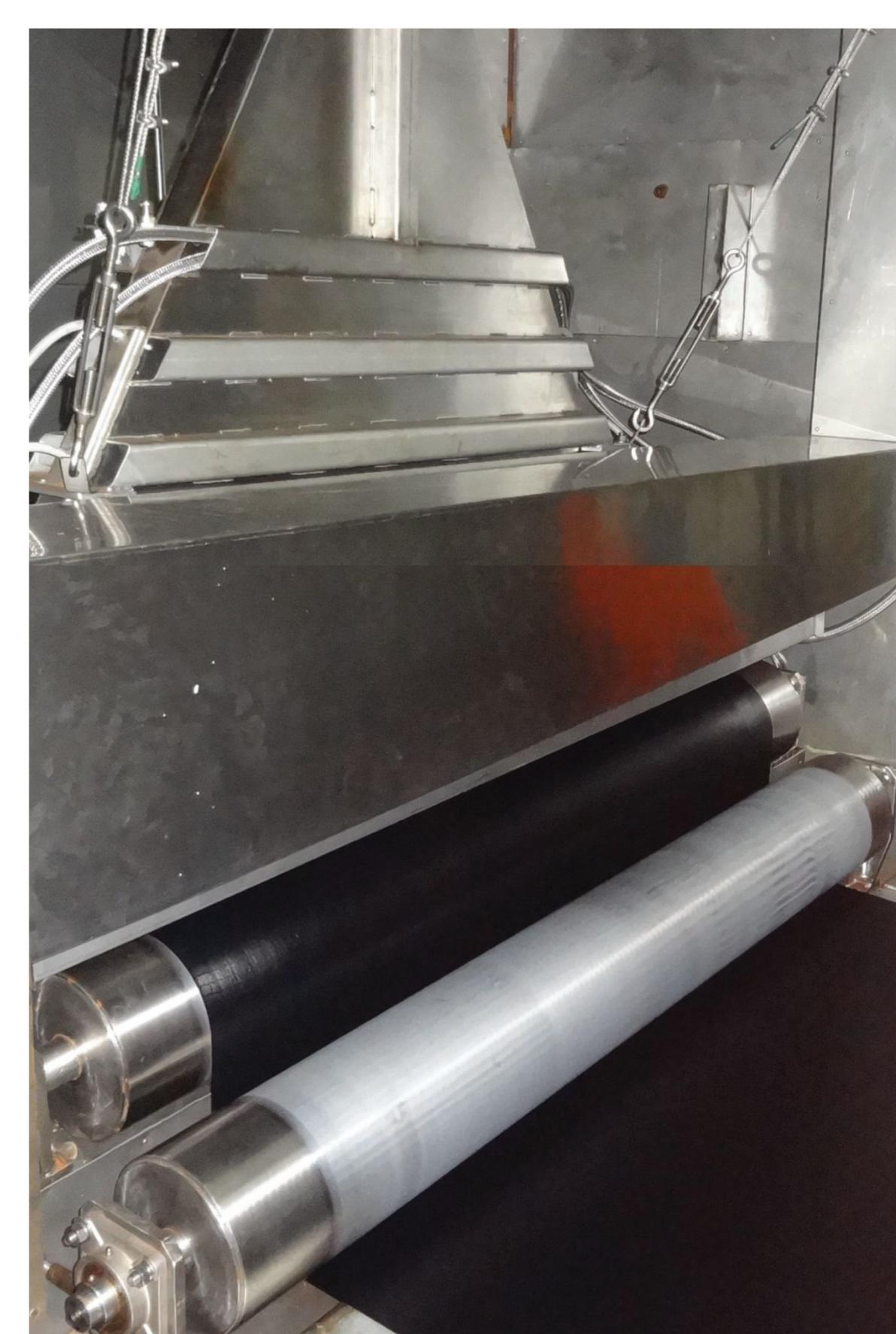


Figure 8: Production under extraction device.